

Docket No.: 50090-275

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Hiroki SHINKAWATA

Serial No.: 09/766,846

Filed: January 23, 2001

Group Art Unit: 2811

Examiner: Hung K. Vu

For: SEMICONDUCTOR DEVICE WITH TRANSFER GATE HAVING GATE INSULATING FILM AND GATE ELECTRODE LAYER (AS AMENDED)

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.



No additional fee is required.



Applicant is entitled to small entity status under 37 CFR 1.27



Also attached: Petition for Extension of Time

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	20	20	0	\$18.00 =	\$0.00
Independent Claims	2	3	0	\$84.00 =	\$0.00
Multiple claims newly presented					\$0.00
Fee for extension of time					\$110.00
Total of Above Calculations					\$0.00
					\$110.00

☒ Please charge my Deposit Account No. 500417 in the amount of \$110.00. An additional copy of this transmittal sheet is submitted herewith.

☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

*Gene Z. Robinson*

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Date: May 15, 2003

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*5/22/03*

*Shm th*

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For: SEMICONDUCTOR DEVICE WITH TRANSFER GATE HAVING GATE  
INSULATING FILM AND GATE ELECTRODE LAYER

AMENDMENT

Commissioner for Patents  
Washington, DC 20231

Sir:

Reconsideration of the rejections imposed in the Office Action dated January 16,  
2003 is solicited in light of the following Amendment and Remarks:

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